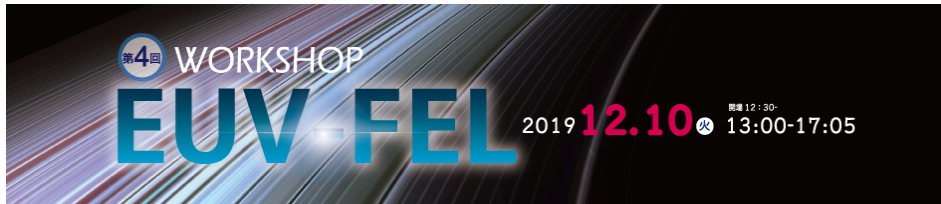


## 4th EUV-FEL Workshop



Contribution ID: 11

Type: **not specified**

### **Study on the soft X-ray FEL light irradiation of resist materials/Kazumasa Okamoto (Osaka Univ.)**

*Tuesday, 10 December 2019 15:30 (30 minutes)*